



MULTI-LAYER INTEGRATED SEMICONDUCTOR STRUCTURE HAVING AN ELECTRICAL
SHIELDING PORTION
Rafael Reif, et al.
Application No. 10/749,096

1/7

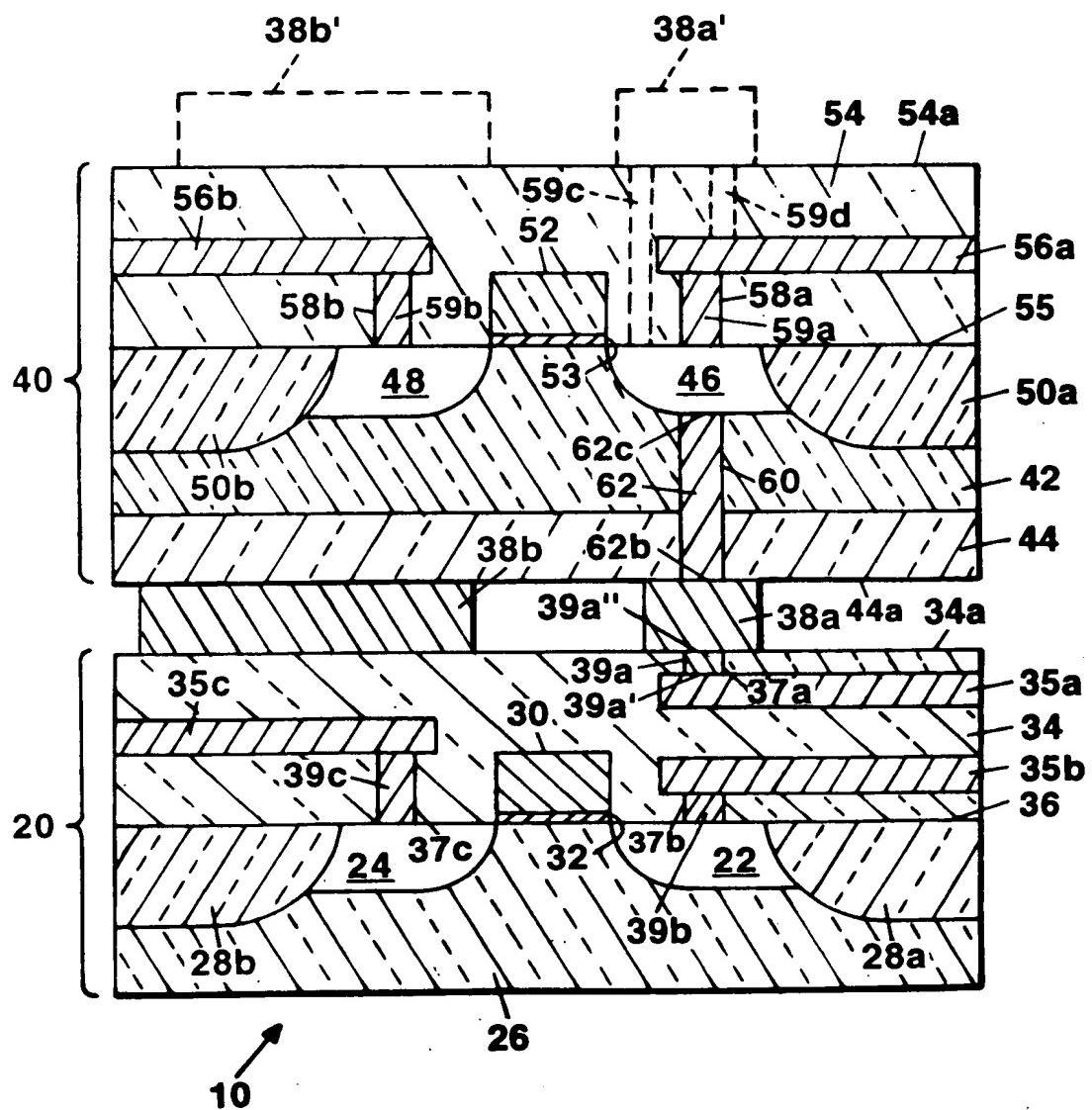


Fig. 1

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2/7

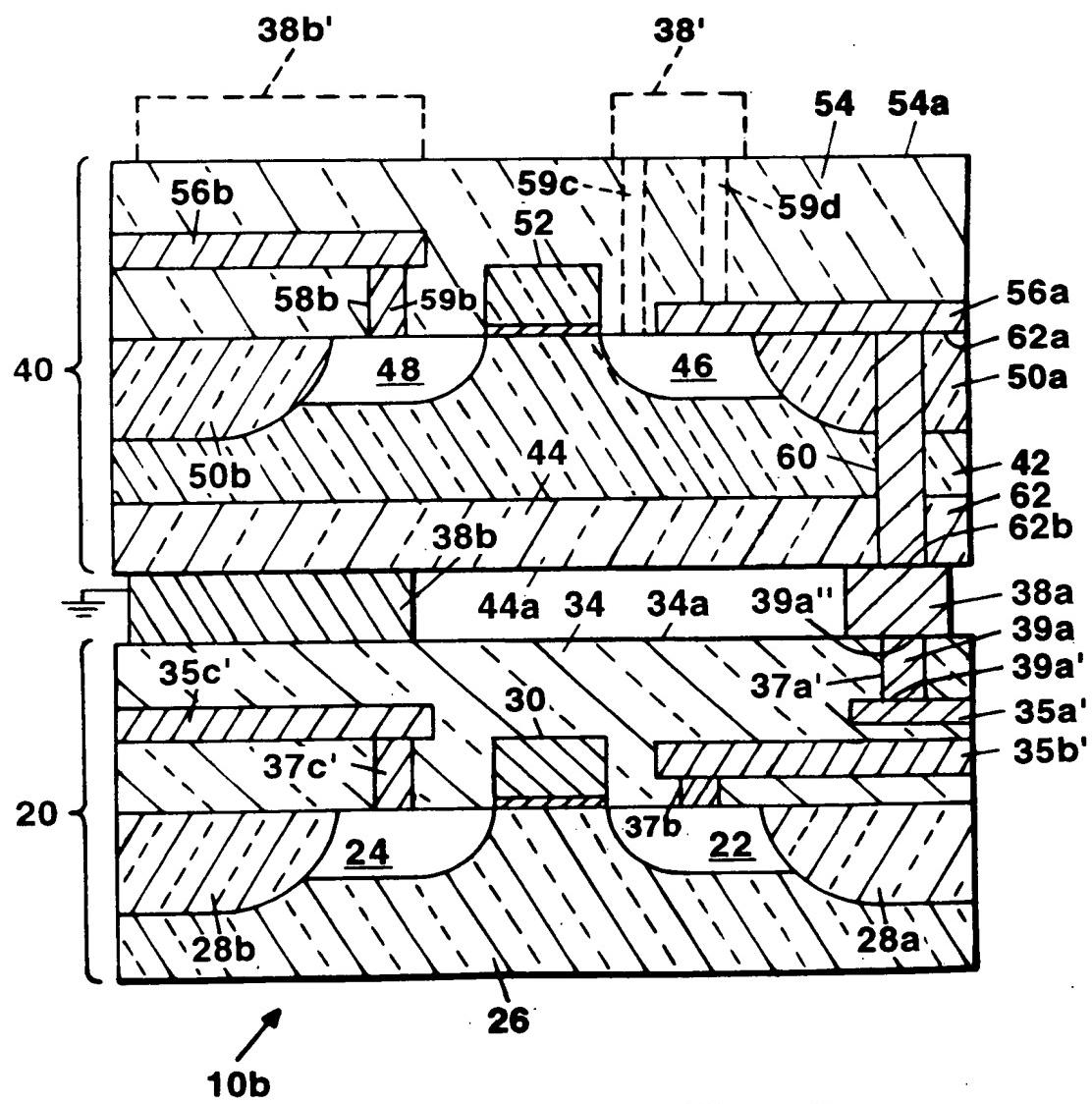


Fig. 2

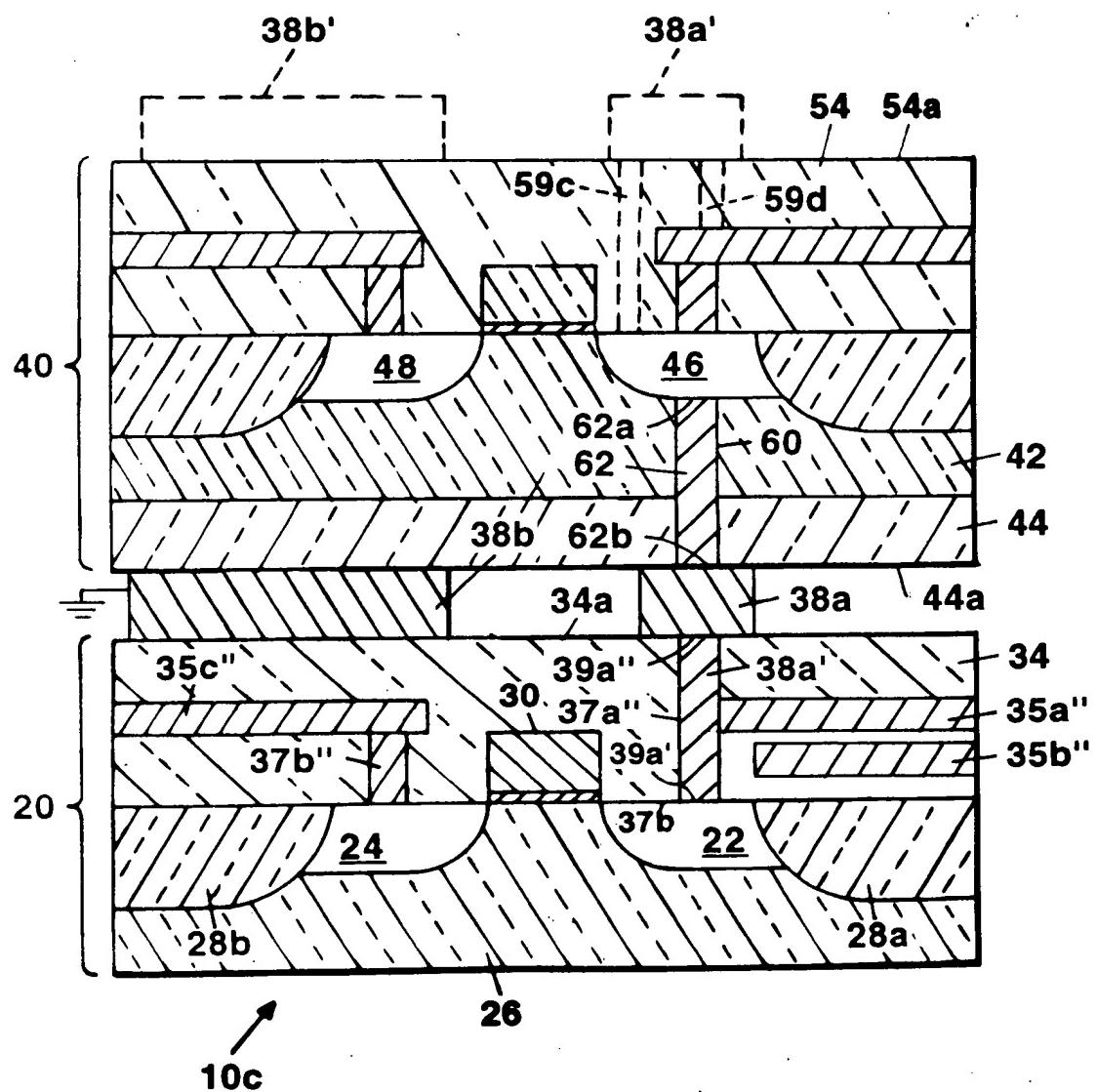


Fig. 3

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4/7

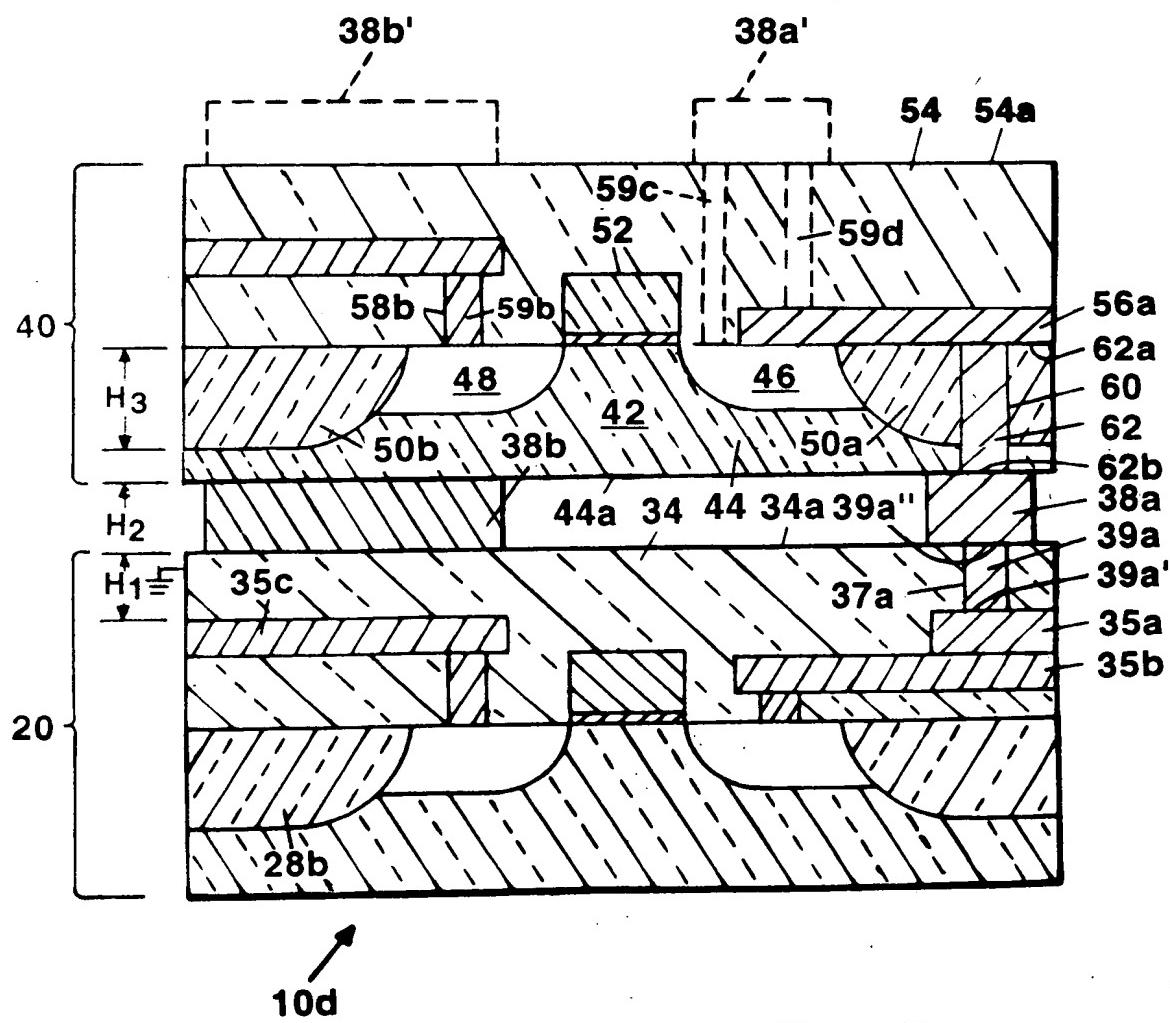


Fig. 4

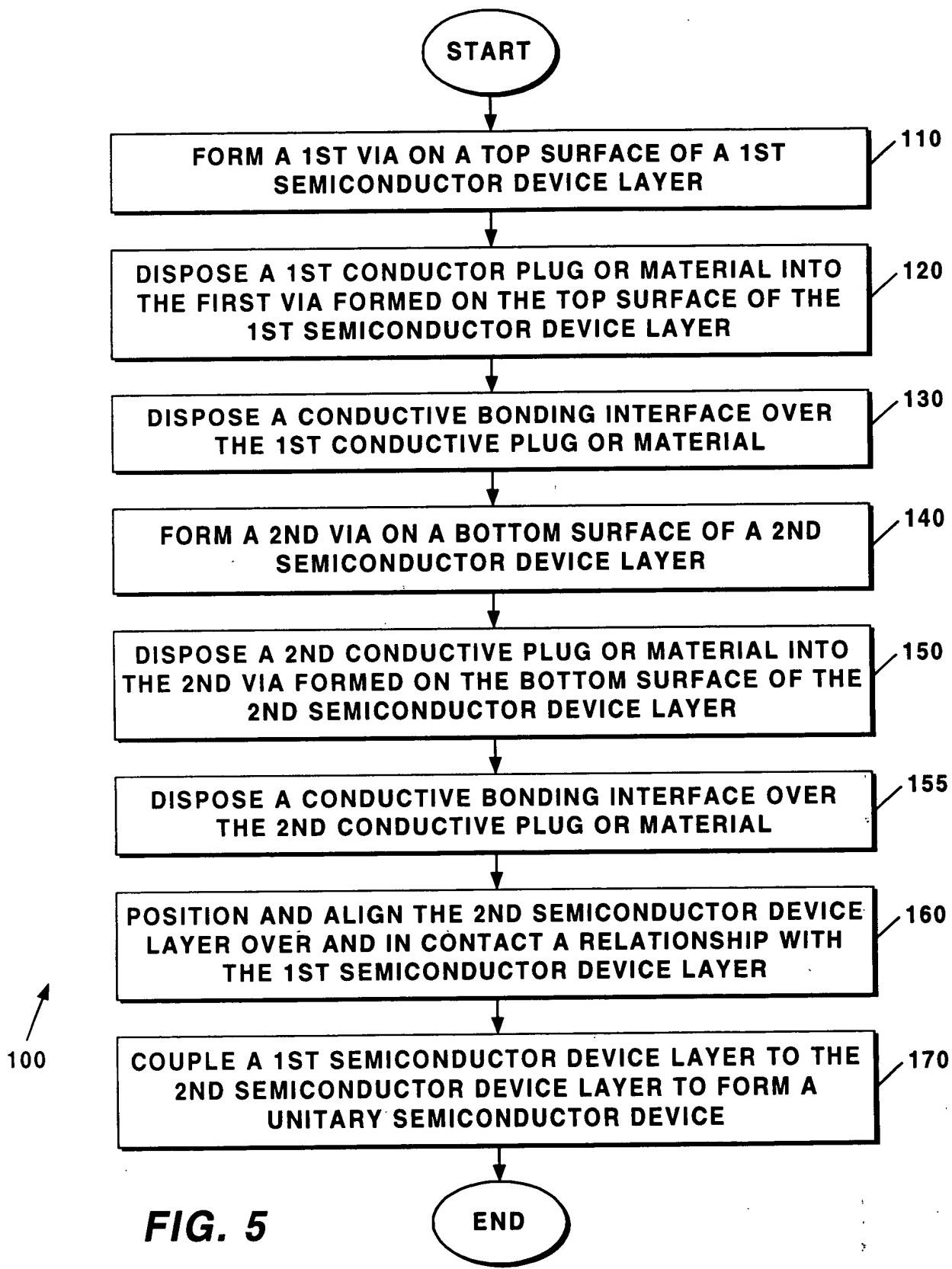


FIG. 5

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Application No. 10/749,096

6/7

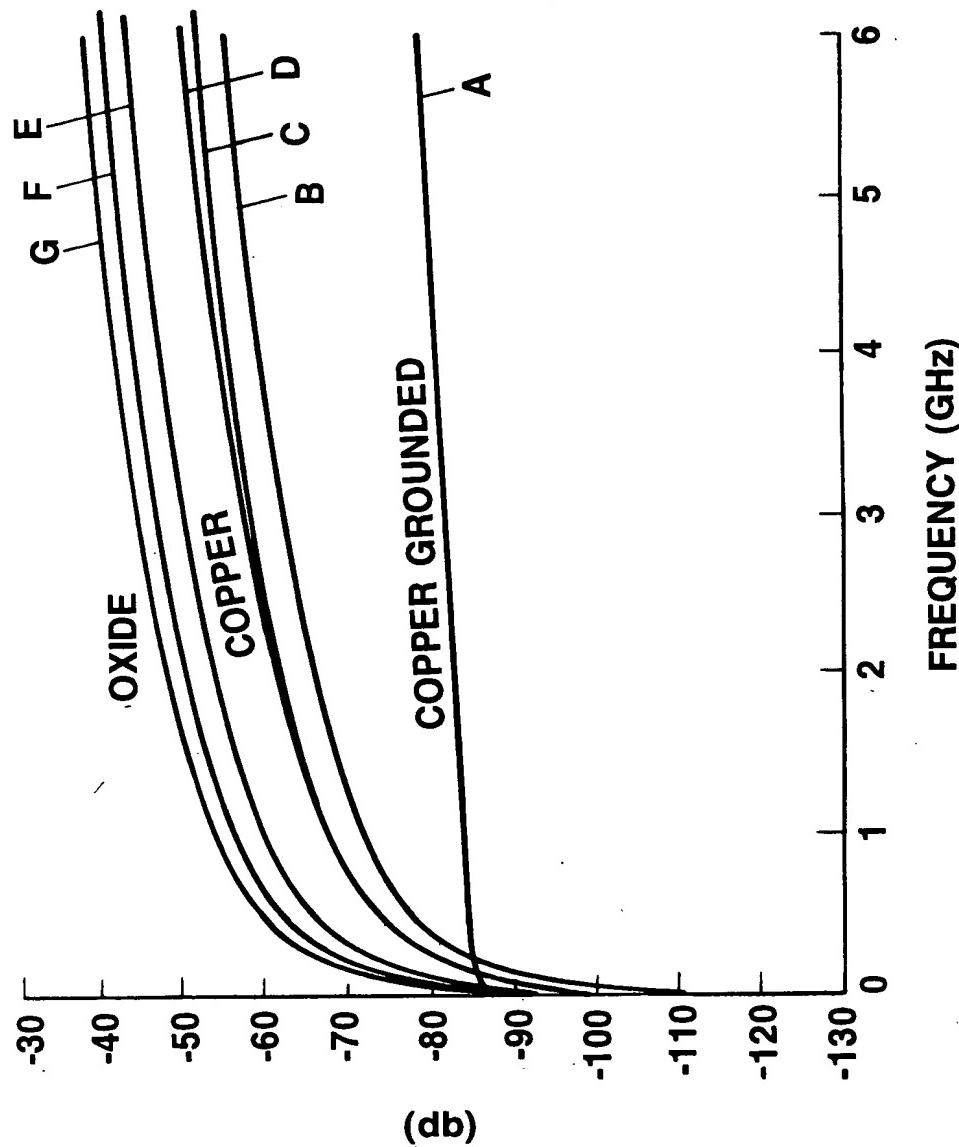


FIG. 6

MULTI-LAYER INTEGRATED SEMICONDUCTOR STRUCTURE HAVING AN ELECTRICAL
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Application No. 10/749,096

7/7

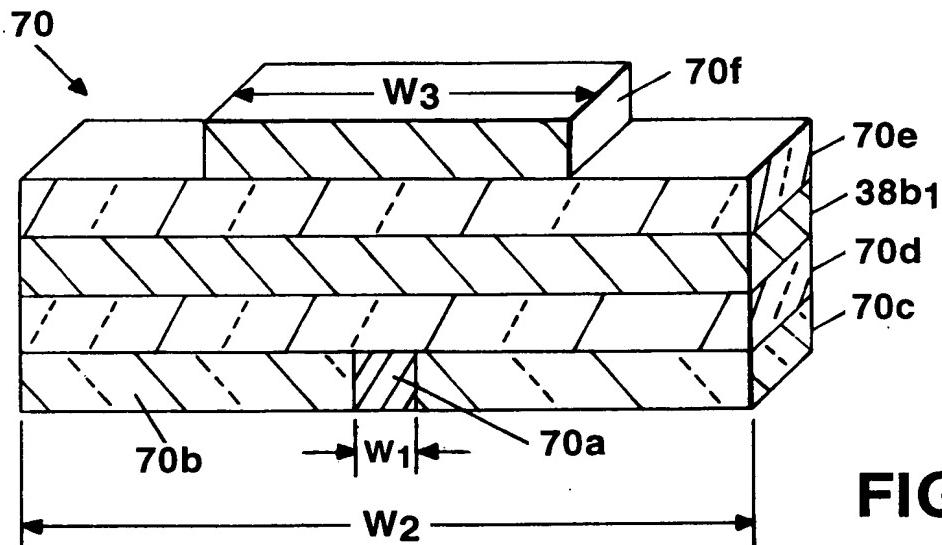


FIG. 7

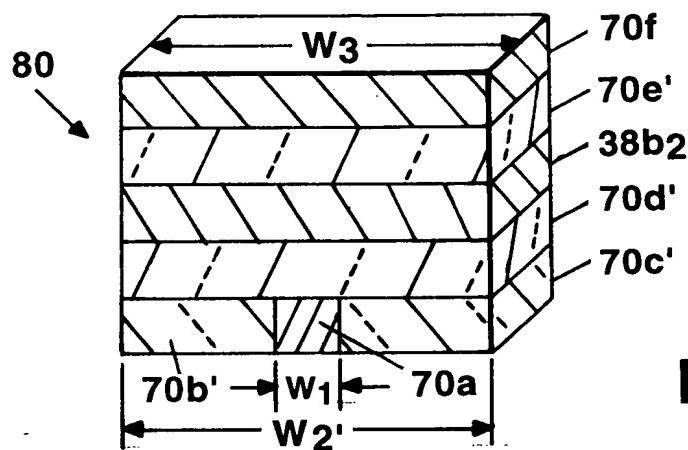


FIG. 8

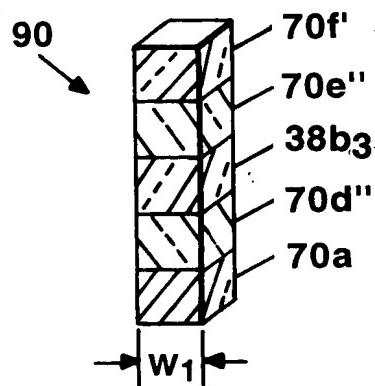


FIG. 9